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BIB DATA SHEET

CONFIRMATION NO. 4877

SERIAL NUMBER	FILING or 371(c) DATE RULE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
10/586,445		117	1792	1110/97825

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**** CONTINUING DATA *******

This application is a 371 of PCT/JP05/01114 01/27/2005

**** FOREIGN APPLICATIONS *******

JAPAN 2004-018313 01/27/2004

**** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ****

05/05/2009

Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No		JAPAN	6	5	4

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TITLE

Method for predicting precipitation behavior of oxygen in silicon single crystal, method for determining production parameter of silicon single crystal, and storage medium for storing program for predicting precipitation behavior of oxygen in silicon single crystal

FILING FEE RECEIVED 1100	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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